



PATENT
Atty. Dkt. No. AMAT/7729/TCG/EPI/RKK

ZFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**Re Application of:
Singh, et al.**

Serial No.: 10/688,797

Filed: October 17, 2003

Confirmation No.: 9712

**For: SILICON-CONTAINING LAYER
DEPOSITION WITH SILICON
COMPOUNDS**

Office of Initial Patent Examination
Filing Receipt Corrections
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Group Art Unit: 1762
Examiner: Unknown

CERTIFICATE OF MAILING
37 CFR 1.8

Dear Sir:

REQUEST FOR CORRECTION OF ERROR ON FILING RECEIPT

The Filing Receipt for the above-referenced application contains an error regarding the Attorney Docket number. The Filing Receipt recites the docket number as "007729". It should read AMAT/7729/TCG/EPI/RKK.

Attached is a copy of the Filing Receipt with the above change noted thereon.
Please correct this error or notify the applicants of the reasons for denying the request.

Respectfully submitted,

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/688,797	10/17/2003	1762	2502	-007729 <i>Appn/7729</i>		66	12

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AMAT/7729/TCG/EPI/RKK
 CONFIRMATION NO. 9712

UPDATED FILING RECEIPT



OC000000013460575

Date Mailed: 08/06/2004



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Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Assignment For Published Patent Application

APPLIED MATERIALS, INC.;

RECD AUG 13 2004

Domestic Priority data as claimed by applicant

This appln claims benefit of 60/419,376 10/18/2002
 and claims benefit of 60/419,426 10/18/2002
 and claims benefit of 60/419,504 10/18/2002

Foreign Applications

If Required, Foreign Filing License Granted: 02/06/2004

Projected Publication Date: 11/11/2004

Non-Publication Request: No

Early Publication Request: No



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Title

Silicon-containing layer deposition with silicon compounds

Preliminary Class

427

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Title 37, Code of Federal Regulations, 5.11 & 5.15**

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